

<b>Notice of References Cited</b>	Application/Control No. 09/990,279	Applicant(s)/Patent Under Reexamination HONG, HYUNG-KI	
	Examiner A. Sefer	Art Unit 2826	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0107538	06-2003	ASAO et al.	345/87
*	B	US-6,014,258	01-2000	Naka et al.	359/618
*	C	US-6,573,882	06-2003	Takabayashi, Hiroshi	345/102
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	GB 2320790	07-1998	UK	Yim et al	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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